

Supporting Information

Multi-state electromagnetic phase modulations in NiCo₂O₄ through cation disorder and hydrogenation

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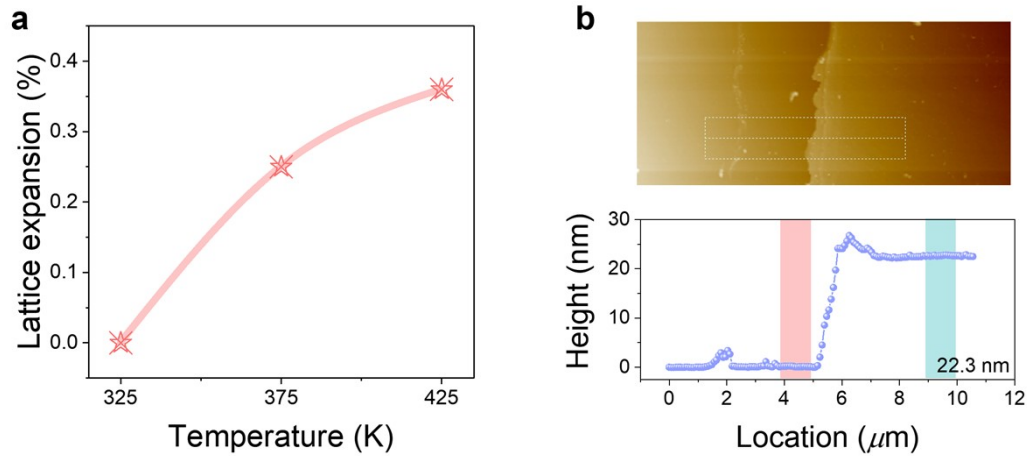
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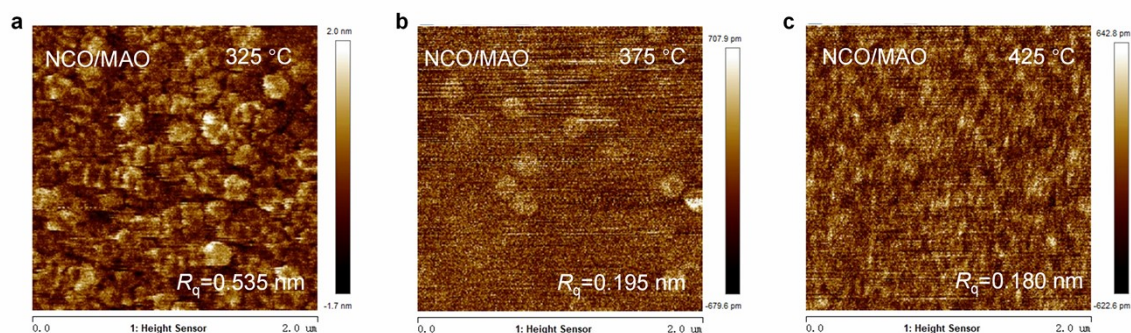
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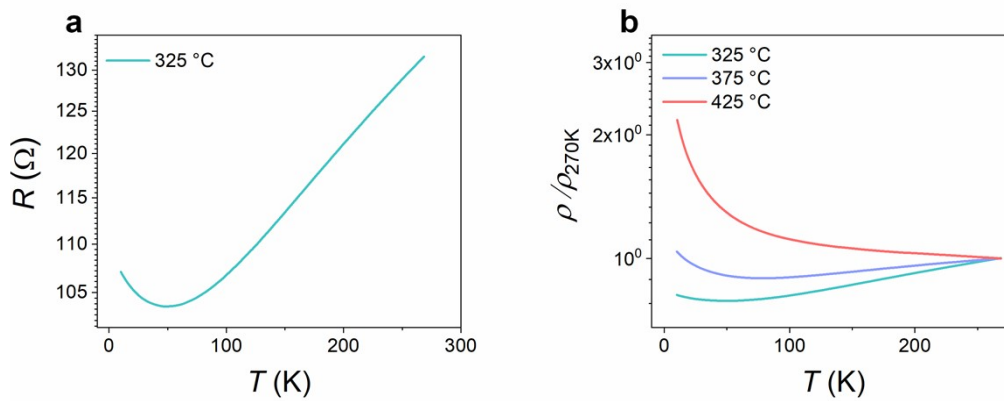
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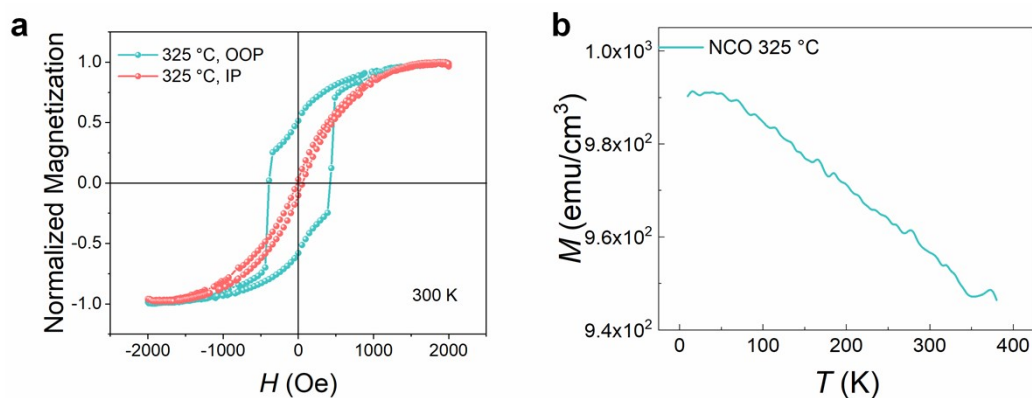
Supplementary Figure 1. a, *Out-of-plane* lattice expansion of NCO films as a function of deposition temperature (T_{sub}). **b**, Atomic force microscope (AFM) images for as-grown 22 nm-thick NCO/MAO (001) heterostructure. Elevated growth temperatures promote cation disorder and the formation of oxygen vacancies, which cause *out-of-plane* lattice expansion and a corresponding low angle shift in the XRD spectra. Concurrently, the NCO films thickness is estimated to be around 22.3 nm using AFM techniques.



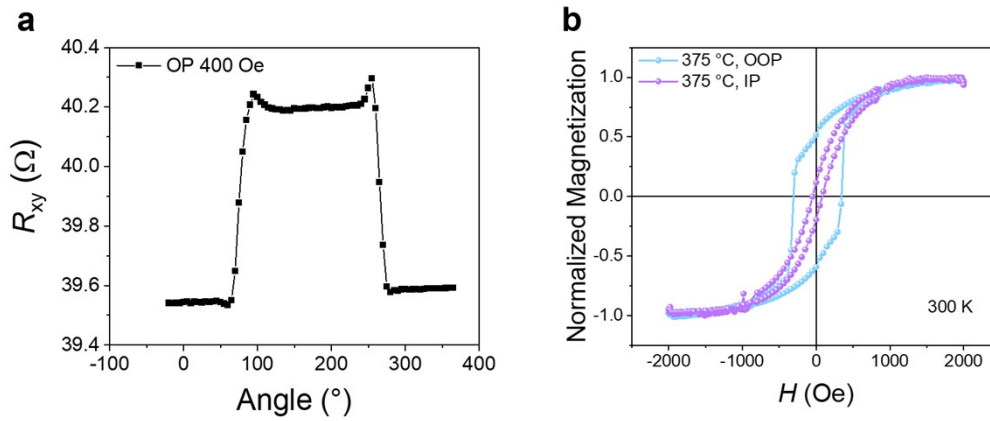
Supplementary Figure 2. Atomic force microscope (AFM) images for as-grown NCO/MAO heterostructure at different growth temperature. The as-grown NCO/MAO films exhibit atomically smooth surfaces, as quantified by AFM with a root-mean-square roughness (R_q) of less than 0.5 nm. Moreover, the surface smoothness of the film improves significantly with increasing growth temperature, a phenomenon attributed to the temperature-dependent plasma dynamics in the PLD process. A higher substrate temperature provides additional energy to the plasma plume, which accelerates its propagation toward the substrate. The arriving adatoms thereby gain higher surface mobility, facilitating more efficient diffusion and incorporation into low-energy lattice sites. This process promotes two-dimensional layer-by-layer growth and ultimately yields a smoother, denser film surface.¹



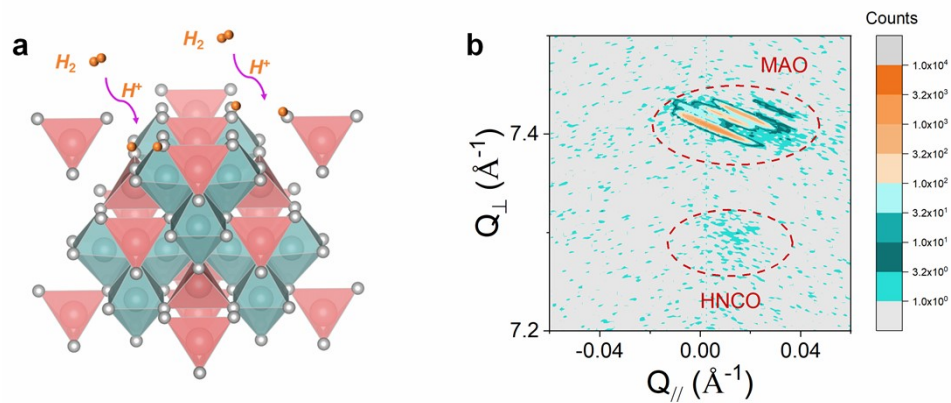
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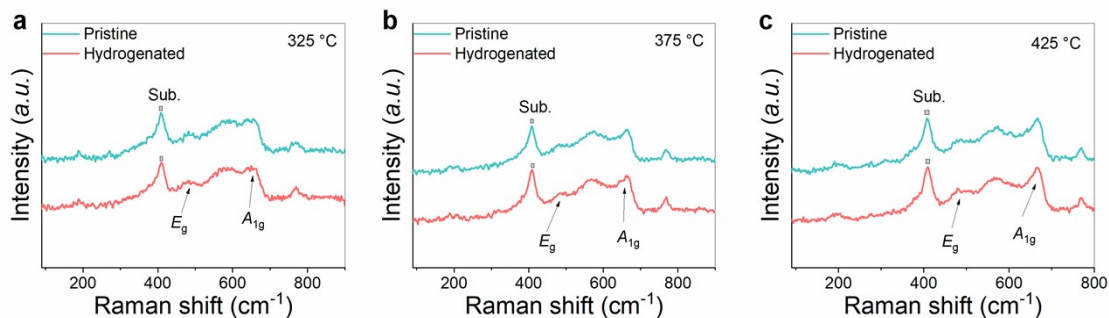
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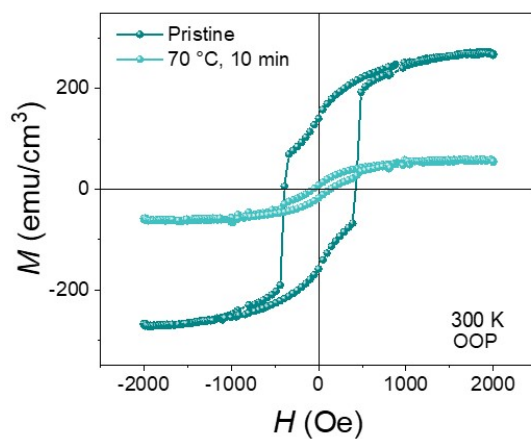
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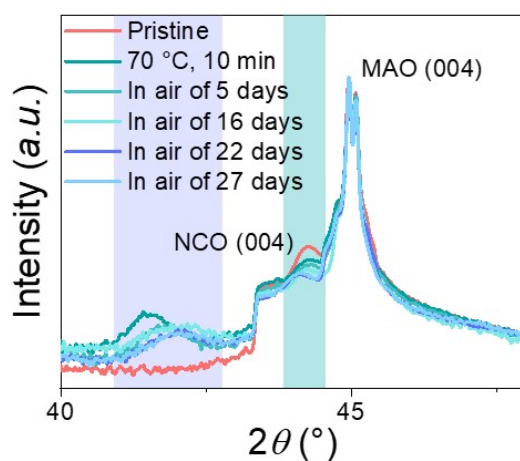
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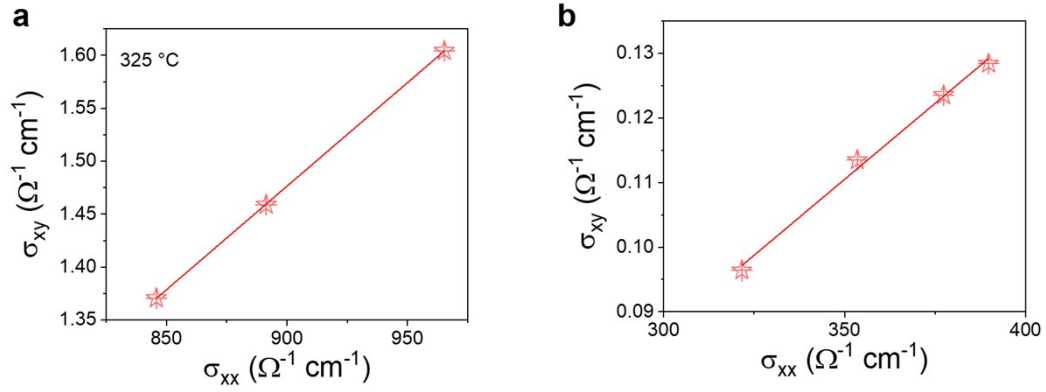
Supplementary Figure 7. Raman spectra comparison between pristine and hydrogenated NCO films deposited at **a**, 325 °C, **b**, 375 °C and **c**, 425 °C. The E_g mode corresponds to the vibration of oxygen atoms perpendicular to the metal-oxygen bonds and is typically associated with the symmetry of octahedral sites (O_h). In contrast, the A_{1g} mode arises from the symmetric stretching vibration of oxygen atoms along the metal-oxygen bonds and is commonly related to the symmetry of tetrahedral sites (T_d).⁴ The characteristic phonon modes of the parent NCO phase are retained after hydrogenation, confirming that the primary lattice framework remains intact, consistent with a topotactic phase transformation.



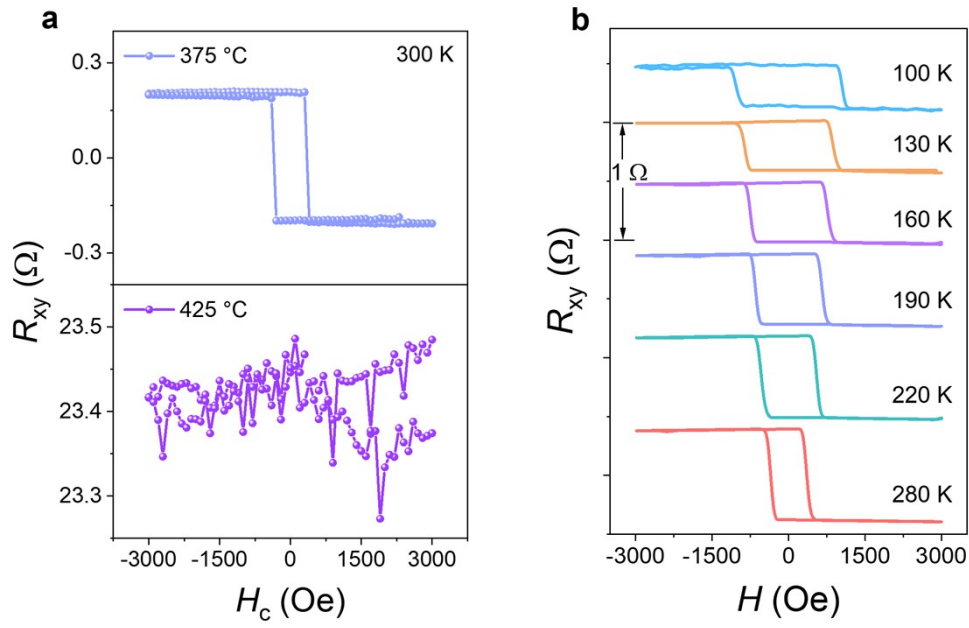
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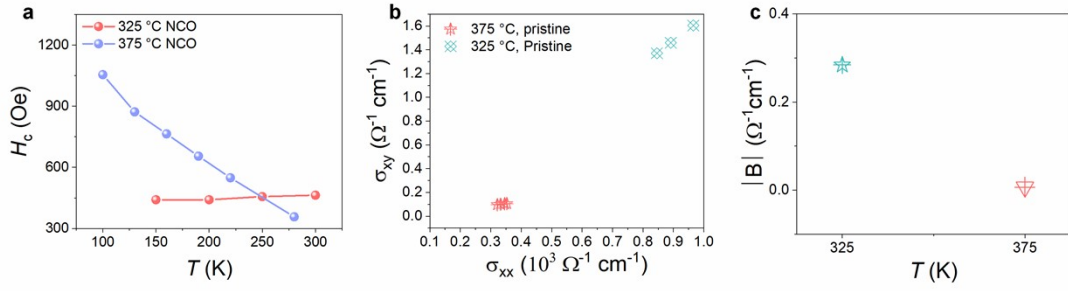
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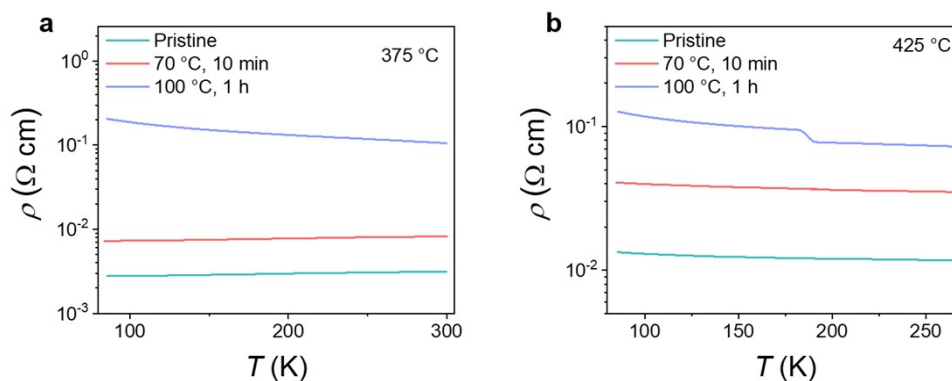
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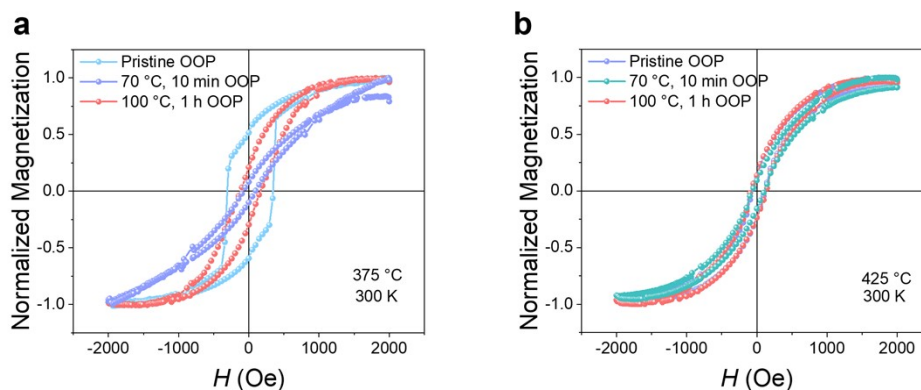
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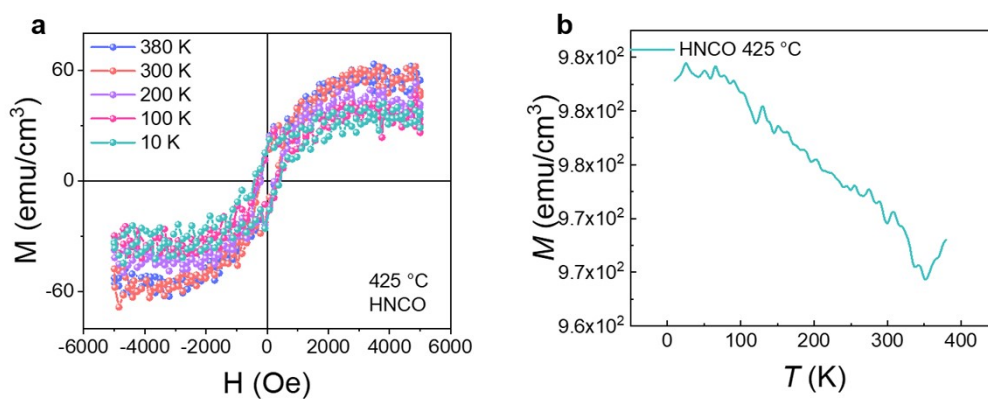
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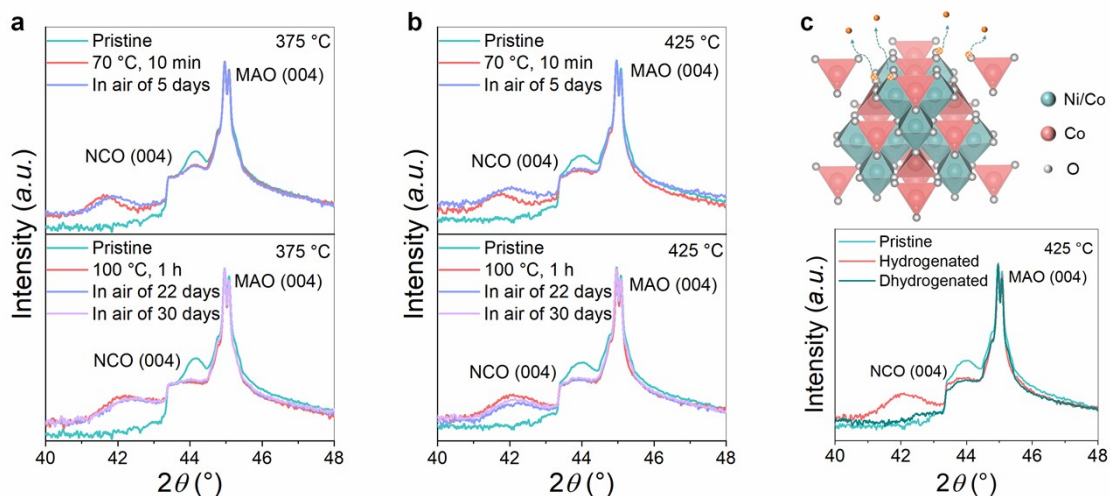
Supplementary Figure 13. a, Temperature-dependent resistivity (ρ - T) curves for pristine and hydrogenated NCO films grown at 375 °C. **b**, ρ - T curves for pristine and hydrogenated NCO films grown at 425 °C. The smaller modulation in resistivity upon hydrogenation indicates that higher cation disorder originating from elevated temperature growth partially suppresses the proton-induced electronic phase evolution. In NCO films with higher cation disorder, hydrogen incorporation exerts a weaker influence on electrical transport than in more ordered films. This suggests that pre-existing structural and electronic disorder kinetically hinders proton-driven carrier localization, highlighting the role of cation disorder as a tuning parameter for hydrogen-related phase transitions.



Supplementary Figure 14. The normalized magnetization hysteresis (M - H) loops compared for pristine and hydrogenated NCO films deposited at **a**, 375 °C and **b**, 425 °C along the OOP and IP directions at 300 K. While hydrogenation effectively tunes the PMA in NCO with low disorder, it shows negligible effect in highly disordered systems. This occurs as the magnetic ground state is already profoundly modified by cation disorder, which leaves insufficient phase space for additional modulation by hydrogen ions.



Supplementary Figure 15. **a**, Temperature-dependent *out-of-plane* M - H loops for NCO deposited at 425°C , measured from 10 K to 380 K. **b**, Temperature-dependent magnetization (M - T) for as-grown NCO/MAO heterostructure at 425°C , measured from 10 K to 380 K.



Supplementary Figure 16. Evolution of XRD patterns with hydrogenation for NCO films grown at **a**, 375 °C and **b**, 425 °C. **c**, XRD patterns compared for NCO/MAO heterostructure upon hydrogenation and dehydrogenation. When exposed to air, the intermediate hydrogenated NCO film exhibits a gradual recovery of its XRD peaks toward the pristine positions. The fully hydrogenated film (100 °C, 1 h) demonstrates higher stability under the same conditions. Moreover, annealing the hydrogenated film in ambient atmosphere (200 °C, 1 h) drives its diffraction pattern close to the original state, confirming the reversibility of the hydrogenation process.

Supplementary References

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